

N THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS:

Chen et al.

SERIAL NUMBER:

09/774,165

GROUP NUMBER:

3742

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January 26, 2001

EXAMINER:

M. Paschall

TITLE:

INTEGRATED PLASMA CHAMBER AND INDUCTIVELY-

COUPLED TOROIDAL PLASMA SOURCE

Terminal Disclaimer

I, Ronald C. Weigner, state that I am a representative authorized to sign on behalf of Applied Science & Technology, Inc., identified below as the assignee of the entire right, title and interest in and to the above-identified patent application, U.S. Serial No. 09/774,165. I, along with legal counsel, have reviewed all the evidentiary documents accompanying or referred to in the instant Terminal Disclaimer and certify that, to the best of my knowledge and belief, title to the above-identified application is in the name of Applied Science & Technology, Inc.

Applied Science & Technology, Inc. of 90 Industrial Way, Wilmington, MA 01887-4610 is the assignee of the entire right, title and interest in and to U.S. Serial No. 09/774,165 by virtue of the Assignments recorded in the United States Patent and Trademark Office at Reel 11833, Frame 0772, on May 24, 2001, and at Reel 12278, Frame 0079, on October 19, 2001 by the inventors in this application to Applied Science & Technology, Inc.

Applied Science & Technology, Inc. hereby waives and disclaims the terminal part of any patent granted on the above-identified application which would extend beyond the full statutory term (which may be longer than seventeen (17) years) of U.S. Patent No. 6,486,431, which issued on November 26, 2002, and hereby agrees that any patent so granted on U.S. Serial No. 09/774,165 shall be enforceable only for and during such period that the legal title to said patent shall be the same as the legal title to U.S. Patent No. 6,486,431, this agreement to run with any patent granted on U.S. Serial No. 09/774,165 and to be binding upon the Assignee, its successors or assigns.

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